

<b>Notice of References Cited</b>	Application/Control No. 09/871,398	Applicant(s)/Patent Under Reexamination LIU ET AL.	
	Examiner Jacob Y. Choi	Art Unit 2875	Page 1 of 1

#### U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-5,584,561	12-1996	Lahos, Etienne	362/473
	B	US-5,624,175	04-1997	Gelormino et al.	362/473
	C	US-5,015,918	05-1991	Copeland, John	315/76
	D	US-5,877,762	03-1999	Young, James A.	715/803
	E	US-4,225,844	09-1980	Lipp et al.	338/135
	F	US-6,832,847	12-2004	Frosythe et al.	362/473
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

#### FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

#### NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.